Silicon-based spin and charge quantum computation

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Abstract

Silicon-based quantum -com puter architectures have attracted attention because of their promise for scalability and their potential for synergetically utilizing the available resources associated with the existing Siltechnology infrastructure. Electronic and nuclear spins of shallow donors (e.g. phosphorus) in Silare ideal candidates for qubits in such proposals due to the relatively long spin coherence times. For these spin qubits, donor electron charge manipulation by external gates is a key ingredient for control and read-out of single-qubit operations, while shallow donor exchange gates are frequently invoked to perform two-qubit operations. More recently, charge qubits based on tunnel coupling in P_2^+ substitutional molecular ions in Si have also been proposed. We discuss the frequently of the building blocks involved in shallow donor quantum computation in silicon, taking into account the peculiarities of silicon electronic structure, in particular the six degenerate states at the conduction band edge. We show that quantum interference among these states does not signi cantly a ect operations involving a single donor, but leads to fast oscillations in electron exchange coupling and on tunnel-coupling strength when the donor pair relative position is changed on a lattice-parameter scale. These studies illustrate the considerable potential as well as the trem endous challenges posed by donor spin and charge as candidates for qubits in silicon.

K ey words: sem iconductors, quantum computation, nanoelectronic devices, spintronics, nanofabrication, donors in silicon.

I. IN TRODUCTION

M ost of the computer-based encryption algorithms presently in use to protect systems accessible to the public, in particular over the Internet, rely on the fact that factoring a large number into its prime factors is so computationally intensive that it is practically in possible. These systems would be vulnerable if faster factoring schemes became viable. The developm ent by Shor, about a decade ago, of a quantum algorithm that can factorize large num bers exponentially faster than the available classical algorithm s [1] thus could m ake the public key encryption scheme potentially vulnerable, and has naturally generated widespread interest in the study of quantum computing and quantum information processing [2, 3]. The exponential speedup of Shor's algorithm is due to the intrinsic quantum parallelism in the superposition principle and the unitary evolution of quantum mechanics. It in plies that a computer made up of entirely quantum mechanical parts, whose evolution is governed by quantum mechanics, would be able to carry out in reasonably short time prime factorization of large numbers that is prohibitively time-consum ing in classical computation, thus revolutionizing cryptography and inform ation theory. Since the invention of Shor's factoring algorithm, it has also been shown that error correction can be done to a quantum system [4], so that a practical quantum computer (QC) does not have to be forever perfect to be useful, as long as quantum error corrections can be carried out. These two key mathematical developments have led to the creation of the new interdisciplinary eld of quantum computation and quantum information.

The elementary unit of a QC is the quantum bit, or qubit, which is a two-level quantum system (j)i and jli). Contrary to a classical bit which is in one of the binary states, either 0 or 1, the state of a qubit could be any quantum -m echanical superposition state of this two-level system : j)i + jli, where and are complex numbers constrained to the norm alization $j \ j^2 + j \ j^2 = 1$. The computation process in a QC consists of a sequence of operations, or logical gates, in terms of locally tailored H am iltonians, changing the states of the qubits through quantum mechanical evolution. Quantum computation generally involves logical gates that m ay a ect the state of a single qubit, i.e. changing f in, ing into f out, outg, as well as multiple-qubit gates. The form alism for quantum information processing is substantially simplied by the following result proven by Barenco et al [5]: A universal set of gates, consisting of all one-qubit quantum gates and a single two-qubit gate,

e.g. the controlled-NOT (C-NOT) gate, may be combined to perform any logic operation on arbitrarily many qubits.

The physical realization of qubits begins with demonstration of one-qubit gates and the C-NOT quantum gate for one and two qubits. A fler successfully performing these basic logic operations at the one and two qubits stage, the next step is to scale up, eventually achieving a large scale QC of 10^6 qubits. So far, 15 is the largest number for which Shor's factorization was in plemented in a physical system [6]. This factorization required coherent control over seven qubits.

M any physical systems have been proposed as candidates for qubits in a QC, ranging from those in atom ic physics, optics, to those in various branches of condensed matter physics [3]. Am ong the more prominent solid state examples are electron or nuclear spins in sem iconductors [7, 8], including electron spin in sem iconductor quantum dots [9, 10] and donor electron or nuclear spins in sem iconductors [11, 12, 13].

Silicon donor-based QC schemes are particularly attractive because doped silicon makes a natural connection between present m icroelectronic devices and perspective quantum mechanical devices. Doping in sem iconductors has had signi cant technological in pact for the past fly years and is the basis of current mostly silicon-based m icroelectronics technology. A s transistors and integrated circuits decrease in size, the physical properties of the devices are becoming sensitive to the actual conguration of in purities [14]. In this context, the rst proposal of donor-based silicon quantum computer (QC) by K and [11], in which the nuclear spins of the monovalent ³¹P in purities in Si are the qubits, has naturally created considerable interest in revisiting all aspects of the donor in purity problem in silicon, particularly in the Sit³¹P system.

In principle, both spin and electronic orbital degrees of freedom can be used as qubits in semiconductor nanostructures. A great advantage of orbital (or equivalently, charge) qubits is that qubit-speci c m easurements are relatively simple because measuring single charge states involves well-developed experimental techniques using single-electron transistors (SET) or equivalent devices [15]. A major disadvantage of solid state charge qubits is that these orbital states are highly susceptible to interactions with the environment that contains all the stray or unintended charges inevitably present in the device, so that the decoherence time is generally far too short (typically picoseconds to nanoseconds) for quantum error correction to be useful. A related problem is that inter-qubit coupling, which is

necessary for the implementation of two-qubit gate operations essential for quantum computation, is often the long-range dipolar coupling for charge qubits. This makes it di cult to scale up the architecture, since decoherence grows with the scaling-up as more and more qubits couple to each other via the long-range dipolar coupling. However, the strong interactions make the orbital states an excellent choice for studying qubit dynamics and qubit coupling in the solid state nanostructure environment.

Spin qubits in sem iconductor nanostructures have com plem entary advantages (and disadvantages) com pared with charge qubits based on quantized orbital states. A real disadvantage of spin qubits is that a single electron spin (not to mention a single nuclear spin) is di cult to measure rapidly, although there is no fundam entalprinciple against the measurement of a Bohrm agneton. The great advantage of spin qubits is the very long spin coherence times, which even for electron spins can be milliseconds in silicon at low temperatures. In addition to the coherence advantage, spin qubits also have a considerable advantage that the exchange gate [9], which provides the inter-qubit coupling, is exponentially short-ranged and nearest-neighbor in nature, thus allow ing precise control and manipulation of two-qubit gates. There is no fundam ental problem arising from the scaling-up of the QC architecture since exchange interaction couples only two nearest-neighbor spin qubits independent of the num ber of qubits.

We provide here a brief perspective on spin and charge qubits in silicon with electron spins or charge states in shallow P donor levels in Sibeing used as qubits. In Sec. II we present some background on the classic problem of the shallow donor in silicon, describing it through two complementary approaches: The electrice mass theory and the tight-binding form alism. In Sec. III we analyze the response of the donor electron to an applied uniform eld, and conclude that electric eld control over the donor electron does not present additional complications due to the Sihost electronic structure characteristics. Sec. IV is devoted to the exchange coupling for a donor pair in Si, which is highly sensitive to interdonor positioning. We review the basic form alism leading to this behavior, and also describe attempts to overcom elit, namely by considering donors in strained Si, and by reining the theoretical form alism for the problem. The feasibility of charge qubits based on P_2^+ molecular ions in Si is investigated in Sec. V, where we focus on the tunnel coupling and charge coherence in terms of electron-phonon coupling.

II. SINGLE DONOR IN SILICON

Silicon is a group-IV element, so that when a Siatom at a lattice site R_0 in the bulk is replaced by a group-V element like P, the simplest description for the electronic behavior of the additional electron is a hydrogenic model, in which this electron is subject to the Si crystal potential perturbed by a screened C oulom b potential produced by the impurity ion:

$$V(\mathbf{r}) = \frac{e^2}{\mathbf{j}\mathbf{r} - R_0 \mathbf{j}}; \qquad (1)$$

The static dielectric constant of Si, = 12:1, indicates that the donor con ning potential is weaker than the bare hydrogen atom potential, leading to larger e ective Bohr radii and sm aller binding energies, so that donors are easily ionized (also known as shallow donors).

In this section we brie y review basic properties concerning the donor ground state wavefunction within two complementary formalisms: The elective mass theory (EMT), which is a reciprocal space formalism, and the tight-binding (TB) formalism, which is a real space scheme. EMT exploits the duality between real and reciprocal space, where delocalization in real space leads to localization in k-space. Since shallow donor wavefunctions are expected to extend over several lattice constants in real space (the lattice parameter of Si crystal is $a_{Si} = 5:4$ A), it is written in terms of the bulk eigenstates for one or a few k-vectors at the lower edge of the conduction band. The TB description is a microscopic atom istic formalism, in which the basis set for the donor wavefunction expansion consists of atom ic orbitals localized at the individual atom s.

A. E ective m ass theory

The bound donor electron H am iltonian for an impurity at site R $_0$ is written as

$$H_0 = H_{SV} + H_{VO}$$
 : (2)

The rst term, H $_{SV}$, is the single-valley K ohn-Luttinger H am iltonian [16], which includes the single particle kinetic energy, the Siperiodic potential, and the screened in purity C oulom b potential in Eq. (1). The second term of Eq. (2), H $_{VO}$, includes the inter-valley coupling e ects due to the presence of the in purity potential.

Following the EMT assumptions, the donor electron eigenfunctions are written on the basis of the six unperturbed Siband edge Bloch states $= u (r)e^{ik} r$ [the conduction

band of bulk Sihas six degenerate minima ($= 1; \ldots; 6$), located along the X axes of the Brillouin zone at jk j $0:85(2 = a_{i})$ from the point]:

$$_{R_{0}}(\mathbf{r}) = \frac{1}{6} \int_{a=1}^{X^{6}} F(\mathbf{r} - R_{0})u(\mathbf{r})e^{i\mathbf{k}} \int_{a=1}^{a=1} F(\mathbf{r} - R_{0})u(\mathbf{r})e^{i\mathbf{k}}$$
(3)

In Eq. (3), F (r R_0) are envelope functions centered at R_0 , for which we adopt the anisotropic Kohn-Luttinger form, e.g., for = z, $F_z(r) = \exp f [(x^2 + y^2)=a^2 + z^2=b^2]^{1=2}g^{=}$ a^2b . The elective Bohr radii a and b are variational parameters chosen to minimize $E_{SV} = h_{R_0} H_{SV} j_{R_0} i$, leading to a = 25 A, b = 14 A, in agreement with the expected increased values with respect to bare atom s.

The H_{SV} ground state is six-fold degenerate. This degeneracy is lifted by the valley-orbit interactions included here in H_{VO}, leading to the nondegenerate (A₁-symmetry) ground state in (3). Fig. 1 gives the charge density $j_{R_0}(r) f$ for this state, where the periodic part of the conduction band edge B loch functions were obtained from ab-initio calculations, as described in Ref. 17. The impurity site R₀, corresponding to the higher charge density, is at the center of the fram e. It is interesting that, except for this central site, regions of high charge concentration and atom ic sites do not necessarily coincide, because the charge distribution periodicity imposed by the plane-wave part of the B loch functions is 2 =k, incommensurate with the lattice period.

B. Tight-binding description for P donor in silicon

The TB Ham iltonian for the impurity problem is written as:

$$H = \int_{ij}^{X} c_{i}^{Y} c_{j} + \int_{ij}^{X} C_{i}^{Y} c_{j} + \int_{ij}^{X} C_{i}^{Y} c_{i}$$
(4)

where i and j label the atom ic sites, and denote the atom ic orbitals and spins, and c_i^y ; c_i are creation and annihilation operators for the atom ic states. We do not include spin-orbit corrections, thus all term s are spin-independent. The matrix elements h_{ij} de ne the on-site energies and rst and second neighbors hopping for the bulk material, for which we take the parametrization given in Ref. 18. The donor in purity potential is included in the perturbation term U (R_i), the same as Eq. (1), but in a discretized form restricted to the lattice sites:

$$U(R_{i}) = \frac{e^{2}}{r_{i}};$$
 (5)

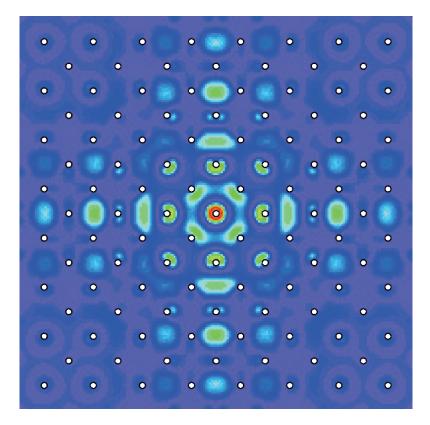


FIG.1: (Color) Electron probability density on the (001) plane of bulk Sifor the ground state of a donor in Siwithin the Kohn-Lutttinger elective mass theory. The white dots give the in-plane atom ic sites.

where r_i is the distance of site i to the impurity site. At the impurity site ($r_i = 0$), the perturbation potential is assigned the value U_0 , a param eter describing central celle ects characteristic of the substitutional species. We take $U_0 = 1:48 \text{ eV}$, which leads to the experimentally observed binding energy of P in Si, 45.6 m eV [19]. Detailed comparison of the TB donor ground state wavefunction with K ohn-Luttinger EM T, performed in Ref. 19, shows that the EM T oscillatory behavior coming from the interference among the planewave part of the six is well captured by the TB envelope function. The good agreement between TB and K & L is limited to distances from the impurity site larger than a few lattice parameters (1 nm). Closer to the impurity, particularly at the impurity site, the TB results become considerably larger than the K & L prediction, in agreement with experiment.

The TB problem is numerically solved by restricting the real-space description to a supercell in which periodic boundary conditions are applied. For the single donor problem, the supercell is taken to be large enough so that convergence in the results is achieved [19, 20].

III. ELECTRIC-FIELD CONTROL OF SHALLOW DONOR IN SILICON

Logic operations in quantum computer architectures based on P donors in Si involve the response of the bound electron wavefunctions to voltages applied to a combination of m etal gates separated by a barrier m aterial (e.g. SiD_2) from the Si host. The A-gate (according to the nom enclature originally proposed by K ane [11]), placed above each donor site, pulls the electron wavefunction away from the donor, aim ing at partial reduction [11] or total cancellation [21] of the electron-nuclear hyper ne coupling in architectures where the qubits are the ³¹P nuclear spins. In a related proposal based on the donor electron spins as qubits [13], the gates drive the electron wavefunction into regions of di erent g-factors, allowing the exchange coupling between neighboring electrons to be tuned.

W e present here a simplied model of the A-gate operation by considering the SiP system under a uniform electric eld and near a barrier. Following Ref. 19, we describe the electronic problem within the TB approach, where the basic H am iltonian is given in Eq. (4), with the perturbation term including the C oulom b potential as in Eq. (5), plus the contribution of a constant electric eld of am plitude E applied along the [001] direction:

$$U(R_{i}) = \frac{e^{2}}{r_{i}}$$
 je je z. (6)

The overall preturbation potential along the z-axis is represented in Fig.2. We take the origin of the potential at the impurity site, R₀, at the center of the supercell. Periodic boundary conditions lead to a discontinuity in the potential at the supercell boundary $z_i = Z_B$, where Z_B is half of the supercell length along [001] or, equivalently, the distance from the impurity to the Si/barrier interface. The potential discontinuity, $V_B = 2jejE Z_B$, actually has a physical meaning in the present study: It models the potential due to the barrier material layer above the Si host (see Fig.2).

A description of the A-gate operations may be inferred from the behavior of the TB envelope function squared (this function is de ned at each lattice site as the sum of the squared TB wavefunction expansion coe cients at this site) at the impurity site under applied eld E, normalized to the zero-eld value:

$$A = A_{0} = j_{TB}^{E} (R_{0}) \hat{f} = j_{TB}^{E=0} (R_{0}) \hat{f}:$$
(7)

The notation here indicates that this ratio should follow a behavior similar to that for the hyper ne coupling constants between the donor nucleus and electron with (A) and without

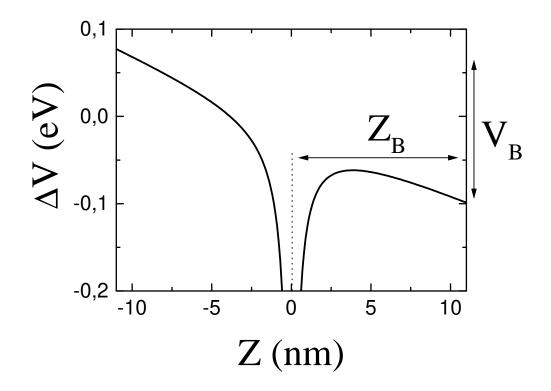


FIG.2: Schem atic representation of the perturbation potential along the z-axis to be added to the bulk SiH am iltonian due to the impurity at R = 0 and to a uniform electric eld in the negative z direction. This particular plot corresponds num erically to a supercell length of $L_z = 40a_{Si}$ and to an electric eld of 80 kV/cm.

 (A_0) external eld. The ratio in (7) is plotted in Fig. 3 (a) for three values of the in purity depth with respect to the Si/barrier interface. Calculations for $Z_B = 10.86$ nm were performed with cubic supercells ($L = 40 a_{Si}$), while for $Z_B = 5.43$ and 21.72 nm tetragonal supercells with $L_x = L_y = 40 a_{Si}$ and $L_z = 20 a_{Si}$ and $80 a_{Si}$ respectively were used. At sm all eld values we obtain a quadratic decay of $A = A_0$ with E, in agreement with the perturbation theory results for the hydrogen atom. At large enough elds, $j \begin{bmatrix} E \\ TB \end{bmatrix} (R_0) f$ becomes vanishingly sm all, and the transition between the two regimes is qualitatively diment according to Z_B : For the largest values of Z_B we get an abrupt transition at a critical eld E_c , while sm aller Z_B (e.g. $Z_B = 5.43$ nm) lead to a sm ooth decay, sim ilar to the one depicted in Ref. 11. In this latter case, we de ne E_c as the eld for which the curve $A = A_0$ vs E has an in ection point, where $A = A_0$ 0.5, thus $E_c (5.43$ nm) = 130 kV/cm. We nd that the decrease of E_c with Z_B follows a simple rule $E_c / 1 = Z_B$, as given by the solid line in Fig. 3 (b).

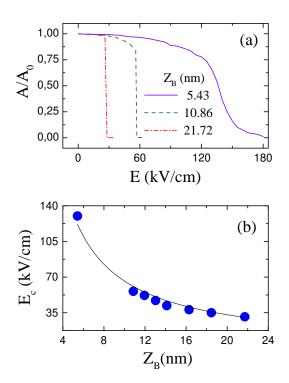


FIG.3: (a) TB envelope function squared at the impurity site under applied eld E, normalized to the zero-eld value, for the indicated values of the impurity-Si/barrier interface distance Z_B . (b) Dependence of the critical eld E_c on Z_B . The solid line is a best t of the form $E_c / 1=Z_B$.

The above results may be understood within a simple picture of the electron in a double well potential, the rst well being most attractive at the inpurity site, $V (R_0 = 0) = U_0$, and the second well at the barrier interface, $V (z = Z_B) = V_B = 2 = \frac{1}{2}E_B$ neglecting the C oulom b potential contribution at the interface. An internal barrier separates the two wells and, for a xed E, this internal barrier height and width increase with Z_B . Deep donor positioning leads to a weaker coupling between the states becalized at each well, even close to level degeneracy, resulting the level crossing behavior of the two lowest donor-electron states illustrated in Fig.4 (a). For a donor positioned closer to the interface, the internal barrier gets weaker, enhancing the coupling between levels localized in each well and leading to wavefunction superposition and to the anticrossing behavior illustrated in Fig.4 (b). The scaling of E_c with $1=Z_B$ m ay also be understood assum ing that the critical eld corresponds to the crossing of the ground state energies of two wells: The C oulom b potential well and an approxim ately triangular well at the barrier. Since the relative depths of the wells increases

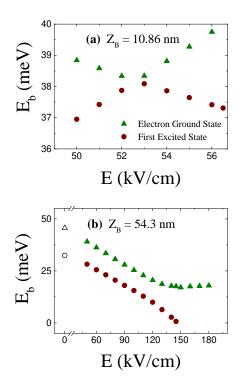


FIG. 4: Calculated binding energies versus electric eld intensity of the two lowest donor electron states. (a) For $Z_B = 10.86$ nm the energies reveal a crossing regime. (b) Anticrossing of the two lowest electron states for $Z_B = 5.43$ nm. The open symbols correspond the zero eld calculated values: 45.6 m eV and 32.4 m eV, in good agreement with experiment.

with $E Z_B$, and assuming that the ground states energies are xed with respect to each well's depth, the $E_c / 1=Z_B$ behavior naturally results.

Them inim um gap at the anticrossing in Fig.4 (b) is ' 9.8 m eV, which allows for adiabatic control of the electron by the A-gate within switching times of the order of picoseconds, as discussed in Ref. [19]. This is a perfectly acceptable time for the operation of A-gates in spin-based SiQC, given the relatively long electron spin coherence times (of the order of a few ms) in Si.

W e rem ark that the B both phases interference behavior in the donor wavefunctions are well captured in the TB wavefunctions, and that the results above demonstrate that electric eld control over single donor wavefunctions, such as proposed in A -gate operations, [11, 13, 21] do not present additional com plications due to the Siband structure. The only critical parameter is the donor positioning below the Si/barrier interface, which should be chosen and controlled according to physical criteria such as those discussed here.

IV. DONOR ELECTRON EXCHANGE IN SILICON

An important issue in the study of donor-based SiQC architecture is coherent manipulations of spin states as required for the quantum gate operations. In particular, two-qubit operations, which are required for a universal QC, involve precise control over electronelectron exchange [9, 11, 13, 22]. Such control can presum ably be achieved by fabrication of donor arrays with well-controlled positioning and surface gate potential [23, 24, 25, 26]. However, electron exchange in bulk silicon has spatial oscillations [27, 28] on the atom ic scale due to valley interference arising from the particular six-fold degeneracy of the bulk Si conduction band. These exchange oscillations place heavy burdens on device fabrication and coherent control [28], because of the very high accuracy and tolerance requirements for placing each donor inside the Si unit cell, and/or for controlling the external gate voltages.

The potentially severe consequences of the exchange-oscillation problem for exchangebased SiQC architecture motivated us and other researchers to perform theoretical studies with increasingly sophisticated form alisms, incorporating perturbation elects due to applied strain [29] orgate elds [30]. These studies, all performed within the standard Heitler-London (HL) form alism [31], essentially recon m the originally reported di culties [28] regarding the sensitivity of the electron exchange coupling to precise atom ic-level donor positioning, indicating that they may not be completely overcom e by applying strain or electric elds. The sensitivity of the calculated exchange coupling to donor relative position originates from interference between the plane-wave parts of the six degenerate B both states associated with the Si conduction-band minim a. M ore recently [17] we have assessed the robustness of the HL approximation for the two-electron donor-pair states by relaxing the phase pinning at donor sites.

In this section, we rst review the main results regarding exchange coupling for a donor pair in relaxed bulk Si, and its high sensitivity to interdonor positioning. We then discuss ways to overcome this behavior, namely considering donors in strained Si and the more general cating-phase HL form alism. We show that strain may partially alleviate the exchange oscillatory behavior, but it cannot entirely overcome the problem. From the cating-phase HL approach results, our main conclusion is that, for all practical purposes, the previously

adopted HL wavefunctions are robust, and the exchange sensitivity to donor positioning obtained in Refs. 28, 29, 30 persists in the more sophisticated theory of Ref. 17.

A. Donor Electron Exchange in Relaxed Bulk Silicon

The HL approximation is a reliable scheme to calculate electron exchange for a wellseparated pair of donors (interdonor distance much larger than the donor Bohr radii) [31]. W ithin HL, the lowest energy singlet and triplet wavefunctions for two electrons bound to a donor pair at sites R_A and R_B , are written as properly symmetrized and normalized combinations of R_A and R_B [as de ned in Eq.(3)]

$${}_{t}^{s}(\mathbf{r}_{1};\mathbf{r}_{2}) = \frac{1}{2(1 \quad S^{2})} [{}_{R_{A}}(\mathbf{r}_{1}) {}_{R_{B}}(\mathbf{r}_{2}) {}_{R_{B}}(\mathbf{r}_{1}) {}_{R_{A}}(\mathbf{r}_{2})]; \qquad (8)$$

where S is the overlap integral and the upper (low er) sign corresponds to the singlet (triplet) state. The energy expectation values for these states, $E_t^s = h_t^s H j_t^s i$, give the exchange splitting through their di erence, $J = E_t - E_s$. We have previously derived the expression for the donor electron exchange splitting [17, 29], which we reproduce here:

$$J(R) = \frac{1}{36} X J(R) \cos(k k) R;$$
(9)

where $R = R_A$ R_B is the interdonor position vector and J (R) are kernels determined by the envelopes and are slowly varying functions of R [28, 29]. Note that Eq. (9) does not involve any oscillatory contribution from u (r), the periodic part of the B loch functions [17, 30]. The physical reason for that is clear from (3): W hile the plane-wave phases of the B loch functions are pinned to the donor sites, leading to the cosine factors in (9), the periodic functions u are pinned to the lattice, regardless of the donor location.

As an example of the consequences of the sensitivity of exchange to interdonor relative positioning, we present in Fig. 5 (a) a case of practical concern involving unintentional donor displacements into nearest-neighbor sites, when the two donors belong to di erent fcc sublattices. The open squares in Fig. 5 (a) give J (R) for substitutional donors along the [100] axis, while the open triangles illustrate the di erent-sublattice positioning situation, namely $R = R_0 + \sum_{N N} w \pm R_0$ along the [100] axis and $\sum_{N N} ranging over the four nearest-neighbors of each <math>R_0$ ($d_{NN} = \sum_{N N} j = a_{si}^{p} = 4$ 2:34A). The lower panel of the gure presents the

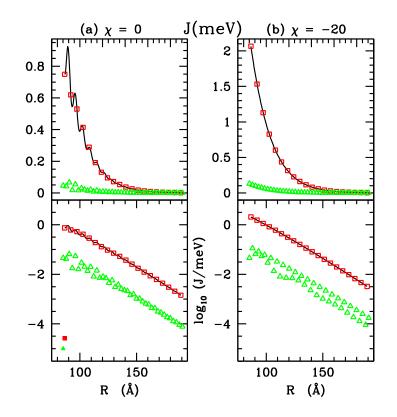


FIG.5: Calculated exchange coupling for a donor pair versus interdonor distance in (a) unstrained and (b) uniaxially strained (along z) Si. The open squares correspond to substitutional donors placed exactly along the [100] axis, the lines give the calculated values for continuously varied interdonor distance along this axis, assuming the envelopes do not change. The open triangles give the exchange for a substitutional pair almost along [100], but with one of the donors displaced by $d_{N N} = 2:3 A$ into a nearest-neighbor site. The lower frames give the same data in a logarithm ic scale. When the loating-phase HL approach is adopted, the results change negligibly; the lied symbols on the lower left frame give examples of calculated corrections (see text).

same data on a logarithm ic scale, showing that nearest-neighbor displacements lead to an exchange coupling reduction by one order of magnitude when compared to J (R $_0$).

B. Strained Si

The extrem e sensitivity of J(R) to interdonor positioning can be eliminated for on-lattice substitutional in purities in uniaxially strained Si (e.g. along the z axis) commensurately grown over Si-G e alloys if inter-donor separation R remains parallel to the interface x-y plane [29]. The strain is accommodated in the Si layer by increasing the bond-length components parallel to the interface and decreasing those along z, breaking the cubic symmetry of the lattice and lowering the six-fold degeneracy of the conduction band minimum to two-fold. In this case, the valley populations in the donor electron ground state wave function in Eq. (3) are not all equal to $1 = \frac{p}{6}$, but are determined from a scalar valley strain parameter , which quantiles the amount of strain. Fig. 5 (b) gives J (R) in uniaxially strained (along z direction) Si for = 20 (corresponding to Si grown over a SiGe alloy with 20% Gecontent) for the same relative positioning of the donor pairs as in Fig. 5 (a). Notice that the exchange coupling is enhanced by about a factor of 2 with respect to the relaxed Si host, but the order-of-m agnitude reduction in J caused by displacements of am plitude d_{NN} into nearest-neighbor sites still persists as \tilde{n}_{NN} is not parallel to the x-y plane.

C. Floating-phase Heitler-London approach

In Refs. 28 and 29, as in the standard HL form alism presented in subsection N-A, it is implicitly assumed that the phases e^{-jk} R_0 in Eq. (3) remain pinned to the respective donor sites $R_0 = R_A$ and R_B , as we adopt single donor wavefunctions to build the twoelectron wavefunction. A lthough phase pinning to the donor substitutional site is required for the ground state of an isolated donor (A_1 symmetry) in order to minimize single electron energy, this is not the case for the lower-symmetry problem of the donor pair. In order to minimize the energy of the two-donor system, here we allow the phases to shift by an amount R along the direction of the interdonor vector $R = R_B = R_A$, so that the single-particle wavefunctions in Eq. (8) become

$$R_{A}(\mathbf{r}) = \frac{1}{6} \int_{a=1}^{X^{6}} F(\mathbf{r} - R_{A})u(\mathbf{r})e^{i\mathbf{k}} (\mathbf{r} - R_{A} + R_{A})$$
 (10)

and

$$R_{B}(\mathbf{r}) = \frac{1}{6} \int_{a=1}^{X^{6}} F(\mathbf{r} - R_{B}) u(\mathbf{r}) e^{i\mathbf{k} (\mathbf{r} - R_{B} - R_{A})} :$$
(11)

We take R as a variational parameter to minimize E_s and E_t . Since the phases in Eq.(3) are responsible for the sensitivity of the exchange coupling to donor positioning in Si, this more general variational treatment might lead to changes in the previously reported [28, 29, 30] behavior of the two-donor exchange splitting $J = E_t$ E_s . M inimization of the total energy for the particular geometry where the donor pair is 87 A apart along the [100] direction leads the singlet energy decrease of 270 neV, and the triplet energy decrease of 6 neV. This results in an increase in J by 264 neV, given by the solid square in the lower left hand side frame of Fig. 5. The oating phases variational scheme leads to a reduction in both singlet and triplet states energy, therefore the net variation in J is positive (negative) if the triplet energy reduction is smaller (larger) than the singlet. The solid triangle in Fig. 5 corresponds to a case of negative variation, obtained when one of the donors in the above geometry is displaced into a nearest-neighbor site. Note that the corrections are more than three orders of magnitude smaller than the calculated J within standard HL. In other words, for all practical purposes the xed-phase standard HL approximation is entirely adequate for the range of interdonor distances of interest for QC applications.

From the perspective of current QC fabrication e orts, 1 nm accuracy in single P atom positioning has been recently demonstrated [24], representing a major step towards the goal of obtaining a regular donor array embedded in single crystal Si. Exchange coupling distributions consistent with such accuracy are presented in Ref. 33, indicating that even such small deviations (1 nm) in the relative position of donor pairs can still lead to signi cant changes in the exchange coupling, favoring J 0 values. Severe limitations in controlling J would come from \hops" into di erent substitutional lattice sites. Therefore, precisely controlling of exchange gates in Si remains an open (and severe) challenge. A s suggested in Ref. 32, spatially resolved m icro-R am an spetroscopy m ight provide a valuable diagnostic tool to characterize local values of exchange coupling between individual spin qubits.

V. CHARGE QUBITS IN SILICON

Successful coherent m anipulation of electron orbital states in G aA shas been achieved for electrons bound to donor in purities [35] as well as electrons in double quantum dots [36]. There were also suggestions of directly using electron orbital states in Si as the building blocks for quantum information processing [37, 38]. Speci cally, a pair of phosphorus donors that sit relatively close to each other (so as to have sizable wave function overlap) form an elective hydrogen molecule in Sihostmaterial. Charge qubitsmay be defined by ionizing one

of the bound electrons, thus leading to a double well potential led with a single electron: The single electron ground state manifold, whether it is the two states localized in each of the wells or their symmetric and anti-symmetric combinations, can then be used as the two-level system forming a charge qubit [39, 40]. The advantage of such a charge qubit is that it is easy to manipulate and detect, while its disadvantage, as already mentioned above, is the generally fast charge decoherence as compared to spin.

In this section we discuss the feasibility of the P_2^+ charge qubit in Si, focusing on single qubit properties in terms of the tunnel coupling between the two phosphorus donors, and charge decoherence of this system in terms of electron-phonon coupling. We take into consideration the multi-valley structure of the Si conduction band and explore whether valley interference could lead to potential problems or advantages with the operations of P_2^+ charge qubits, such as di culties in the control of tunnel coupling similar to the control of exchange in two-electron systems discussed in Sec. IV, or favorable decoherence properties through vanishing electron-phonon coupling.

A. The P_2^+ molecule in Silicon

We study the simple situation where a single electron is shared by a donor pair, constituting a P_2^+ m olecule in Si. The charge qubit here consists of the two lowest energy orbital states of an ionized P_2 m olecule in Si with only one valence electron in the outerm ost shell shared by the two P atom s. The key issue to be exam ined is the tunnel coupling and the resulting coherent superposition of one-electron states, rather than the entanglem ent am ong electrons, as occurs for an exchange-coupled pair of electrons.

The donors are at substitutional sites R_A and R_B in an otherwise perfect Sistructure. In the absence of an external bias, we write the eigenstates for the two lowest-energy states as a superposition of single-donor ground state wavefunctions [as given in Eq. (3)] localized at each donor, $_A$ (r) and $_B$ (r), sim ilar to the standard approximation for the H_2^+ molecular ion [31]. The symmetry of the molecule leads to two eigenstates on this basis, namely the symmetric and antisymmetric superpositions

$$(\mathbf{r}) = -\frac{\mathbb{A}(\mathbf{r})}{2(1 - S)} \cdot \mathbf{r}$$
(12)

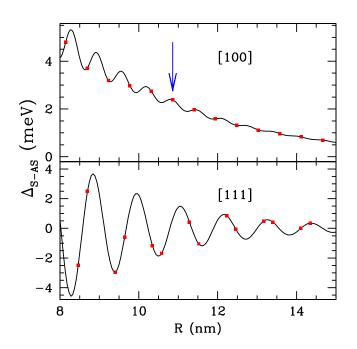


FIG. 6: Symmetric-antisymmetric gap for the P_2^+ molecular ion in Si for the donor pair along the indicated lattice directions. The arrow in the upper frame indicates the target con guration analyzed in Fig. 7.

As described in Ref. 34, the energy gap between these two states may be written as

$$_{S AS} = \frac{2}{1 S^2} X^6 (R) \cos(k R);$$
 (13)

where S is the overlap integral between $_{A}$ (r) and $_{B}$ (r). For $R = R_{A}$ R_{B} a;b, the amplitudes (R) are monotonically decaying functions of the interdonor distance R, and S 1. The dependence of on R jis qualitatively similar to the symmetric-antisymmetric gap in the H_{2}^{+} molecule, namely an exponential decay with power-law prefactors. The main di erence here comes from the cosine factors, which are related to the oscillatory behavior of the donor wavefunction in Si arising from the Si conduction band valley degeneracy, and to the presence of two pinning centers.

Fig. 6 shows the calculated gaps as a function of R for a donor pair along two highsymmetry crystal directions. Two points are worth emphasizing here, which are manifestly di erent from the corresponding hydrogenic molecular ion behavior: (i) $_{\rm SAS}$ is an

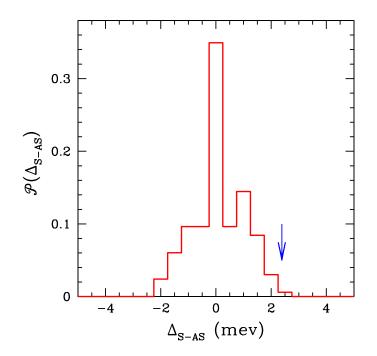


FIG.7: Probability distribution of the sym m etric-antisym m etric gap for the P_2^+ m olecular ion in Si. D onor pairs are approximately aligned along [100], but with an uncertainty radius $R_u = 1$ nm with respect to this target axial alignment (see text). The arrow indicates the gap value for the target conguration, for which the uncertainty radius is $R_u = 0$. Notice that the distribution is peaked at $_{S-AS} = 0$, and not at the target gap value.

anisotropic and fast oscillatory function of R; (ii) the sign of $_{S-AS}$ may be positive or negative depending on the precise value of R. The characteristics mentioned in point (i) are similar to the exchange coupling behavior previously discussed for the two-electrons neutral donor pair.[17, 28, 29] Point (ii) in plies that the P_2^+ molecular ion ground state in Si may be symmetric (as in the H_2^+ molecular ion case) or antisymmetric depending on the separation between the two P atom s. Note that for the two-electron case, the ground state is always a singlet (i.e. a symmetric two-particle spatial part of the wavefunction with the spin part being antisymmetric), in plying that the exchange J is always positive for a two-electron molecule. For a one-electron ionized molecule, however, the ground state spatial wavefunction can be either symmetric or antisymmetric.

Fig. 7 shows the normalized probability distribution for the sas gap values when the

rst donor is kept xed at R $_{\rm A}$ and the second donor is placed at a site 20 lattice parameters away (108.6A), along the [100] axis. This target con guration is indicated by an arrow in Fig. 6. We allow the second donor position R_B to visit all possible substitutional diam ond lattice positions within a sphere of radius R_u centered at the attempted position. Our motivation here is to simulate the realistic fabrication of a P_2^+ molecular ion with xed inter-atom ic distance in Siw ith the state of the art Sitechnology, in which there will always 3 nm) uncertainty in the precise positioning of the substitutional be a small (R₁₁ 1 donor atom within the Siunit cell. We would like to estimate the resultant random ness or uncertainty in $_{S AS}$ arising from this uncertainty in R_B . For $R_u = 0$, i.e., for $R = 20a_{Si}$, $_{\rm S~AS}$ ' 2:4 meV, given by the arrows in Fig. 7. We incorporate the e ect of small uncertainties by taking $R_u = 1 \text{nm}$, corresponding to the best reported degree of accuracy in single P atom positioning in Si [24]. These small deviations completely change the qubit gap distribution, as given by the histogram in Fig. 7, strongly peaked around zero. Further increasing R_u leads to broader distributions of the gap values, though still peaked at zero [34]. This broadening is due to the fast increase in the number of lattice sites inside the sphere of radius R_u , thus contributing to the distribution, as R_u increases. We conclude that the valley interference between the six B loch states leads to a strong suppression of the qubit delity since the most probable s As tends to be zero.

A very small $_{S-AS}$ is undesirable in de ning the two states jli and jli form ing the charge qubit. If we take them to be the symmetric and anti-symmetric states given in Eq. (12), the fact that they are essentially degenerate means that, when one attempts to initialize the qubit state at jli, a dierent combination jli+ jlimight result. Well de ned qubits may still be de ned under a suitable applied external bias, so that the electron ground state wavefunction is localized around one of the donors, say at lattice site R_A , and the rst excited state is localized around R_B .

Single qubit rotations, used to implement universal quantum gates [2], might in principle be achieved by adiabatic tunneling of the electron among the two sites under controlled axially aligned electric elds through bias sweeps [41]. When, at zero bias, the ground state is not well separated by a gap from the rst excited state, severe limitations are expected in the adiabatic manipulation of the electron by applied external elds. In other words, the delity of the single qubit system de ning the quantum two-level dynamics will be severely com promised by the valley interference electron.

B. Electron-phonon coupling

Two key decoherence channels for charge qubits in solids are background charge uctuations and electron-phonon coupling [36]. The form er is closely related to the sam ple quality (e.g., existences of stray charges and charged defects in the system) and is extrinsic, while the latter is intrinsic. Here we focus on the electron-phonon coupling. A critical question for the P_2^+ m olecular ion in Si is whether the Sibandstructure and the associated charge density oscillations [17] lead to any signi cant m odi cation of the electron-phonon coupling m atrix elem ents. The relevant terms for the electron-phonon interaction in Si takes the form :

$$H_{ep} = D \sum_{q}^{X} \frac{h}{2_{m} V !_{q}} jqj (q) (a_{q} + a_{q}^{Y}); \qquad (14)$$

where D is the deform ation constant, $_{m}$ is the mass density of the host material, V is the volume of the sample, a_{q} and $a^{y}{}_{q}$ are phonon annihilation and creation operators, and (q) is the Fourier transform of the electron density operator. For the two-donor situation, where we are only interested in the two lowest energy single-electron eigenstates, the electron-phonon coupling Hamiltonian is conveniently written in this quasi-two-level basis in terms of the Pauli spin matrices $_{x}$ and $_{z}$ (where spin up and down states refer to the two electronic eigenstates, labeled fj+i; j ig):

$$H_{ep} = D \frac{X}{q} \frac{h}{2 m V!_{q}} \frac{!_{1=2}}{jqj(A_{r x} + A, z)} a_{q} + a^{y}_{q} ;$$

$$A_{r} = h \frac{je^{iq}}{j!} \frac{r_{j}}{!} i;$$

$$A, = \frac{1}{2} h + je^{iq} \frac{r_{j}}{!} i h \frac{jq}{!} \frac{r_{j}}{!} i : \qquad (15)$$

Here the term proportional to $_x$ can lead to transition between the two electronic eigenstates and is related to relaxation; while the term proportional to $_z$ only causes energy renorm alization of the two electronic levels, but no state mixing, so that it only leads to pure dephasing for the electronic charge states.

Calculations of the matrix elements involved in Eq. (15), reported in Ref. 34, lead to the conclusion that the electron-phonon coupling for a P_2^+ m olecular ion in Si form ally behaves very similarly to that for a single electron trapped in a GaAs double quantum dot. For example, the relaxation matrix element is proportional to

$$A_{r} = (ab \quad a \, be^{iq \ R})^{2} \quad dr \, e^{iq \ T} (r)^{2} + (j_{0} j_{1}^{2} j_{2}^{2})^{2} \quad dr \, e^{iq \ T} (r)' (r \quad R); \qquad (16)$$

where the more complicated multi-valley bandstructure of Si and the strong inter-valley coupling introduced by the phosphorus donor atom s only strongly a left the origin (thus small) contribution to the electron-phonon coupling, so that they do not cause signi cant changes in the overall electron-phonon coupling matrix elements. Therefore, available estimates[41, 42] of decoherence induced by electron-phonon coupling based on a single-valley hydrogenic approximation in the P_2^+ system in Si should be valid. In other words, the multi-valley quantum interference elect does not provide any particular advantage (or disadvantage) for single qubit decoherence in the SiP donor charge-based QC architecture.

VI. SUMMARY

In summary, we have brie y reviewed physical aspects related to some of the relevant building blocks for the implementation of donor spin and charge qubits in silicon: Electric eld control of a single donor, the exchange gate for two spin qubit operations, control and coherence of P_2^+ charge qubits. Our results indicate that, although some of the operations may be implemented as originally conceived, the spin and charge qubits based on donors in silicon pose immense challenges in terms of precise nanostructure fabrications because of the degenerate nature of the silicon conduction band. Further studies of fabrication and innovative alternative approaches are imperative in order to fully realize the potential of donor-based QC architectures.

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